MEMC 3003(01-0650) PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Holder

Art Unit 1765

Serial No. 10/002,862 Filed November 15, 2001 Confirmation No. 4783

For INTERMITTENT FEEDING TECHNIQUE FOR INCREASING THE MELTING RATE OF POLYCRYSTALLINE SILICON

January 23, 2004

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VIRGINIA 22313-1450

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## SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R. 1.97 and 1.98 and MPEP 609, and in compliance with the duty of disclosure set forth in 37 C.F.R. 1.56, applicant submits copies of the references listed on the attached PTO/SB/08A for consideration by the Patent and Trademark Office in the above-entitled application and to be made of record therein.

Respectfully submitted,

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Express Mail Label No. EV 272753249 US

PTO/SB				Complete if Known			
1	SECOND SUPI			Application Number	10/002,862		
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(use as many sheets as necessary)				Confirmation Number	4783		
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Sheet	1	of	1	Attorney Docket No.	MEMC 3003)01-0650)		

			U.S.	PATENT	DOCUMENT	S		
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